

APPLICATION DATA SHEET

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METHOD FOR FABRICATING THIN-FILM TRANSISTOR**Legal Representative:**

Attorney or Agent:	Eric J. Robinson
Registration Number:	38285
Attorney or Agent:	Jeffrey L. Costellia
Registration Number:	35483
Attorney or Agent:	Donald R. Studebaker
Registration Number:	32815
Attorney or Agent:	Jason H. Vick
Registration Number:	45285
Attorney or Agent:	Charles M. Leedom
Registration Number:	26477
Attorney or Agent:	David S. Safran
Registration Number:	27997

Customer Number Correspondence Address: 22204
22204

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Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.
 398, Hase,
 Atsugi-shi 243-0036 Kanagawa-ken JP
INVENTOR(s):

Primary Citizenship:	JP
Given Name:	Hongyong
Family Name:	ZHANG
Residence City:	Yamato-shi
Residence Country:	JP
Address:	Paresu Miyagami 302, 1-10-15, Fukamidai, Yamato-shi Kanagawa, 242 JP